

Title (en)

PH-SENSITIVE MICROSENSOR AND A METHOD OF MANUFACTURING IT

Title (de)

PH-SENSITIVER MIKROSENSOR, SOWIE VERFAHREN ZU SEINER HERSTELLUNG

Title (fr)

MICROCAPTEUR SENSIBLE AU PH ET PROCEDE DE FABRICATION ASSOCIE

Publication

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Application

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Abstract (en)

[origin: WO9639624A1] The invention concerns a pH-sensitive microsensor with sensor diaphragm. The latter is formed by laser ablation and can be produced by ablation from aluminium oxide or another material. This results in a sensor with very low drift.

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